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PATENT
DOCKET NO.: 29273/516

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: Shigeo MORIYAMA, et al.

SERIAL NO. : 09/462,912

FILED : January 18, 2000

FOR : POLISHING APPARATUS AND METHOD FOR PRODUCING
SEMICONDUCTORS USING THE APPARATUS

ART UNIT : 3723

EXAMINER : Willie Berry, Jr.

COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

SIR:

In response to the office action of October 28, 2003, the period for response having been extended herein to April 28, 2004 by payment of the requisite fee of \$950.00 for a Petition for Extension of Time Under 37 C.F.R. § 1.136(a), kindly amend the above-identified application as follows:

04/29/2004 YPOLITE1 00000035 110600 09462912
01 FC:1253 950.00 DA

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TECHNOLOGY CENTER R3700